## IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: Min-Hung LEE et al.

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Appl. No.:

NEW

Group: UNASSIGNED

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Examiner: UNASSIGNED

For:

STRAINED SILICON CARBON ALLOY MOSFET STRUCTURE AND FABRICATION METHOD THEREOF

## PRELIMINARY AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 March 4, 2004

Sir:

following preliminary amendments and remarks are respectfully submitted in connection with the above-identified application.

This amendment includes: amendments to the specification and Remarks.